

ABSTRACT

A contactor apparatus having a first  
contactor (2) and a second contactor (4) acquires an  
5 electrical conduction to a plurality of  
semiconductor devices formed on a semiconductor  
wafer (6). The first contactor (2) has contacts  
(2b) which are directly brought into contact with  
power supply terminals (6a) of the semiconductor  
10 devices. The second contactor (4) is movable  
relative to the first contactor (2) and has contacts  
(4a) which are brought into contact with signal  
terminals (6b) of the semiconductor devices.  
Thereby, the number of contacts to be formed on a  
15 single contactor can be reduced and the number of  
pattern wirings can also be reduced, which makes the  
fabrication of the contactor easier.